

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Kangguo CHENG et al.

Group Art Unit: 2891

Appln. No. : 10/710,608

Examiner: Reames, M.

Filed : July 23, 2004

Confirmation No.: 4607

For : PATTERNED STRAINED SEMICONDUCTOR SUBSTRATE AND
DEVICE

AMENDMENT UNDER 37 C.F.R. §1.116

Commissioner for Patents
U.S. Patent and Trademark Office
Customer Service Window, Mail Stop AF
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir:

In response to the Final Office Action dated October 16, 2007, and as a supplement to the Request for Reconsideration filed on December 17, 2007, Applicants respectfully request reconsideration and allowance of the application in view of the following amendments and remarks.

A listing of claims begins on page 2.

Remarks begin on page 5.

If extensions of time are necessary to prevent abandonment of this application, then such extensions of time are hereby petitioned under 37 C.F.R. §1.136(a), and any fees required therefor (including fees for net addition of claims) are hereby authorized to be charged to Deposit Account No. 09-0458.